

Docket No.: 202450US0/sal

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Atsushi SHIOTA, et al.

SERIAL NUMBER: 09/770,289

GROUP: 1712

FILED: January 29, 2001

EXAMINER: FEELY, MICHAEL J

FOR: PROCESS FOR PRODUCING SILICA-BASED FILM, SILICA-BASED FILM,  
INSULATING FILM, AND SEMICONDUCTOR DEVICE

**LETTER**

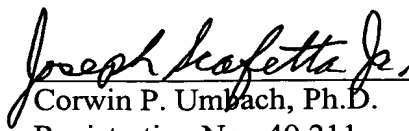
MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

**In the matter of the above-identified application, please note that no foreign  
priority is being claimed.**

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.  
Norman F. Oblon

  
Corwin P. Umbach, Ph.D.

Registration No. 40,211

Joseph Scafetta, Jr.

Registration No. 26,803

Customer Number

**22850**

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/04)

DOCKET NO.: 202450US0/sal



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**APPLICATION OF PREVIOUSLY PAID ISSUE FEE IN  
ACCORDANCE WITH SECTION 1308.01 MPEP**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

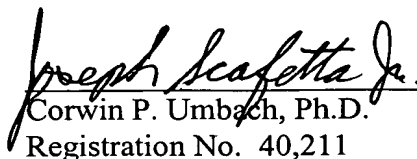
Sir:

The above-identified application was withdrawn from Issue after payment of the Issue Fee in the amount of \$1610 (Issue Fee \$1280.00 + Pub. Fee \$300.00 + Adv. Patent Copies \$30.00). Enclosed is a credit card form in the amount of \$90.00 to include the increase in the Issue Fee.

The application has now been allowed again and since a refund of the previously paid Issue Fee has not been requested, it is now requested that the previously paid Issue Fee be applied to the Issue Fee being paid herewith. Enclosed herewith is copy of the Notice of Withdrawal from Issue.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.  
Norman F. Oblon

  
Corwin P. Umbach, Ph.D.  
Registration No. 40,211

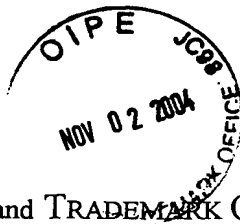
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20245050



UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND  
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
WWW.USPTO.GOV



NOV 27 2001

#12

In re Application of:  
Atsushi Shiota, et al.  
Serial No. 09/770,289  
Filed: January 29, 2001  
For: PROCESS FOR PRODUCING  
SILICA-BASED FILM, SILICA-BASED  
FILM, INSULATING FILM, AND SEMI-  
CONDUCTOR DEVICE

NOTICE OF WITHDRAWAL  
FROM ISSUE UNDER  
37 CFR 1.313 (b)

The above-identified application is withdrawn from issue after payment of the issue fee due to: reopening of prosecution. See 37 CFR 1.31(b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Robert Dawson at (703) 306-2340.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including applicant of the new status of this application.

*Richard V. Fisher*

Richard V. Fisher, Director  
Technology Center 1700  
Chemical and Materials Engineering

RECEIVED: 12/2/02  
OBLON, SPIVAK, McCLELLAND  
MAIER & NEUSTADT, P.C.

DOCKETING DEPT

Initials/Date Docketed: HSH 12/2/02

Type of Resp(s):

Due Date(s):

CCFY

09/770,289

-2-

Oblon, Spivak, McClelland Maier  
& Neustadt PC  
Fourth Floor  
1755 Jefferson Davis Highway  
Arlington, VA 22202

Cc: Allowed Files-PK3-910

**CCPY**